

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813 Examiner: Jack S. J. Chen

In Re PATENT APPLICATION of:

Applicant(s):	Toshikazu MIZUKOSHI	
Serial No.:	10/635,506	INFORMATION.
Filed:	August 7, 2003	INFORMATION DISCLOSURE STATEMENT WITH
For:	METHOD OF FABRICATING A SEMICONDUCTOR DEVICE TRENCH HAVING AN OXIDE FILM ON A CORNERED PORTION THEREOF	CERTIFICATION AND FEE
Docket No :	OKI 361	1

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

This is an Information Disclosure Statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(d)(1) and (2), i.e., after the mailing date of a final Office Action on the merits, but before payment of the issue fee, with certification and the fee set forth in § 1.17(p).

Attached is a copy of a Japanese patent publication, which was cited in the attached Japanese Office Action, dated October 19, 2004. Also attached is an English-language translation of the Japanese Office Action, from which any relevance of the Japanese patent publication may be gleaned. Also listed for consideration is U.S. patent publication Number US 6,187,648 dated February 13, 2001, which is the U.S. counterpart of the Japanese Patent publication, and from which any further relevance of the Japanese Patent publication can by gleaned. The Japanese patent publication was first cited by the Japanese Patent Office in connection with a counterpart application. The publications are listed on the attached Form PTO-1449.

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Please charge any further
fee to our Deposit Accoun
No. 18-0002

Atty. Dkt.: OKI 361

It is hereby certified that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this information disclosure statement, and/or no item of information contained in the information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the person signing the certification after making reasonable inquiry, no item of information contained in the information disclosure statement was known to any individual designated in § 1.56 (c) more than three months prior to the filing of the information disclosure statement.

In compliance with 37 C.F.R. §1.97, the \$180 fee, set forth in 37 C.F.R. 1.17(p), is included in a remittance that is being submitted concurrently herewith. Should this remittance be accidentally missing or insufficient, however, or should any additional fees be required, the Commissioner is hereby authorized to charge such fees to our Deposit Account Number 18-0002.

Consideration of the listed documents respectfully is requested.

January 18, 2005

Date

Robert H. Berdo, Jr. (Reg. No. 38,075)

RABIN & BERDO, P.C.

Respectfully submitted.

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Customer No. 23995

RHB:vm

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FORM PTO-1449				Atty. Docket	Application	Application No.		
INFORMATION DISCLOSURE STATEMENT			EMENT	ОКІ 361	10/6	10/635,506		
				Applicant(s) Toshikazu MIZUKOSHI				
				Filing Date August 7, 2003	Group 2813			
			U.	S. PATENT DOCUMENTS				
Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date	
	AA	US 6,187,648	02/13/01	Doi et al.				
	AB							
	AC							
	AD							
	AE							
	AF							
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	АН							
			FORE	IGN PATENT DOCUMENTS	•	•		
		Document Number	Date	Country	Class	Sub- Class	Trans- lation	
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